



IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Howard Lee Tigelaar Docket No: TI-35614  
Serial No: 10/650,104 Conf. No: 6426  
Examiner: Kevin V. Quinto Art Unit: 2826  
Filed: 08/26/2003  
For: INTEGRATED CIRCUIT MOS TRANSISTOR WITH REDUCED DRAIN AND SOURCE  
RESISTANCE (As amended)

AMENDMENT UNDER 37 C.F.R. § 1.111

Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

MAILING CERTIFICATE UNDER 37 C.F.R. §1.8(a)  
I hereby certify that the above correspondence is being  
deposited with the U.S. Postal Service with sufficient postage  
as First Class Mail in an envelope addressed to:  
Commissioner for Patents, P.O. Box 1450, Alexandria, VA  
22313-1450 on 2-25-05.

Ann Trent  
Ann Trent

Dear Sir:

Responsive to the Office Action mailed December 3, 2004, in connection with the  
above identified application, Applicant respectfully submits the following amendments  
and remarks.